Inventors: Jung et al.

For: "Methods of Manufacturing a Semiconductor Device"

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FIG. 1 (PRIOR ART)

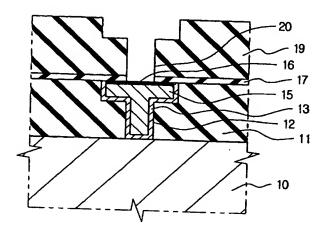
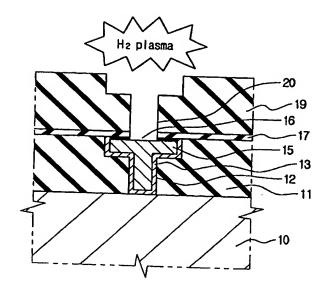


FIG. 2 (PRIOR ART)



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FIG. 3

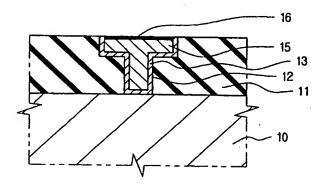
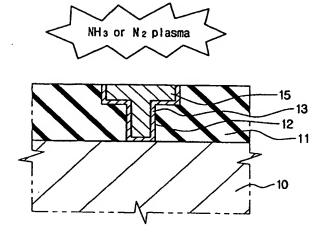


FIG. 4



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FIG. 5

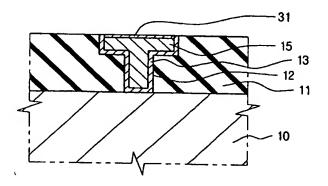
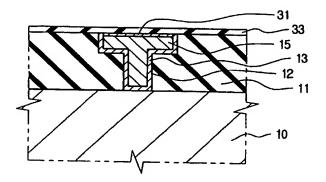


FIG. 6



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FIG. 7

